

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Henry A. Hill  
Serial No. : 10/734,994  
Filed : December 12, 2003  
Title : IN-PROCESS CORRECTION OF STAGE MIRROR DEFORMATIONS  
DURING A PHOTOLITHOGRAPHY EXPOSURE CYCLE

Art Unit : 2851  
Examiner : Peter B. Kim

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

PETITION FOR ONE-MONTH EXTENSION OF TIME

Pursuant to 37 CFR §1.136, applicant hereby petitions that the period for response to the action dated April 14, 2005, be extended for one month to and including August 14, 2005.

Enclosed is a check for \$120 for the required fee. Please apply any other charges or credits to Deposit Account No. 06-1050, referencing 09712-208001.

Respectfully submitted,

Date: August 12, 2005



Marc M. Wefers  
Reg. No. 56,842

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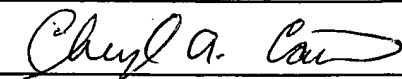
CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

August 12, 2005

Date of Deposit

Signature



Cheryl A. Caron

Typed or Printed Name of Person Signing Certificate

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